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CNT 8 TRA Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Complete if Known 10/815,116 Application Number. March 31, 2004 Filing Date Kirchner et al. First Named Inventor 2851 **Art Unit** Gutierrez Examiner Name

(use as many sheets as necessary)

Attorney Docket Number OST-041134 2

			U.S. PATENT	DOCUMENTS	Pages, Columns, Lines, Where
examiner C	te Doc	current Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
nitials' N	US-5,117 US-5,739 US-6,549 US-6,549 US-2001	,899 5,239	05/26/1992 04/14/1998 08/31/1999 04/15/2003 11/15/2001 05/16/2002 01/02/2003	Shiraishi et al. Nishi et al. Taniguchi Ota Suzuki Mann et al. Van Der Warf et al.	

	FOREIGN PATENT DOCUMENTS				Pages, Columns, Lines,	
Examiner Initials*	Cite No.	Foreign Patent Document Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY 09/27/2000	Name of Patentee or Applicant of Cited Document Nikon Corporation	Where Relevant Passages or Relevant Figures Appear	T°
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	Filing Date	March 31, 2004			
INFORMATION DISCLOSURE	First Named Inventor	Kirchner et al.			
STATEMENT BY APPLICANT		2851			
STATEMENT BY ALL FLOOR	Art Unit Examiner Name	Gutierrez, K.			
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		1737-1747. DAVID M. WILLIAMSON, entitled "Compensator selection in the tolerancing of a microlithographic lens," published by The Perkin-Elmer Corporation of Norwalk, Connecticut, 1989, SPIE Vol. 1049, Pages 178-186.	
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